

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2813
Junichi SATO)	Examiner: Laura M. Schillinger
)	
Application No.: 10/828,882)	
Filed: April 21, 2004)	
)	
For: SEMICONDUCTOR THIN FILM)	
AND METHOD OF FABRICATING)	
SEMICONDUCTOR THIN FILM,)	Confirmation No.: 5622
APPARATUS FOR FABRICATING)	
SINGLE CRYSTAL SEMICONDUCTOR)	
THIN FILM, AND METHOD OF)	
FABRICATING SINGLE CRYSTAL THIN)	
FILM, SINGLE CRYSTAL THIN FILM)	
SUBSTRATE, AND SEMICONDUCTOR)	
DEVICE)	

November 22, 2006

FILED ELECTRONICALLY VIA EFS-WEB

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

UNDER 37 C.F.R. § 1.111

Dear Sir:

In response to the Office Action of August 23, 2006, Applicants request the Examiner consider the following amendments and remarks.